

Accurately measuring feedstock impurities at increasingly lower concentrations is critical to process efficiency and profitability. For example, producers of high-purity monomers face stiff competition and tight purity specifications. Research and production operations in the food, pharmaceutical, chemical, and semi-conductor industries require high-purity gases as well.

Failure to characterize impurities in feedstock streams can render the gas unfit for a given application. Trace contaminants can also contribute to equipment corrosion and reduced polymer yields. Worst of all, they can cause catalyst degradation, poisoning, and contamination — leading to costly downtime and catalyst bed replacement.

# Confidently detect trace contaminants in process feedstocks and finished products immediately after installation

Based on Agilent 7890B GC system, **Permanent Gas and Trace Impurity Analyzers** are factory-configured and chemically tested to measure permanent gases in refinery and natural gas streams. They can also detect sub-ppm-level contaminants in high-purity gases, monomers, and other light hydrocarbon streams.



Agilent Permanent Gas and Trace Impurity Analyzers include innovative technology and reflect our stringent quality control process. Systems include:

### **Factory**

- · System setup and leak testing
- · Instrument checkout
- · Installation of appropriate columns
- Factory-run checkout method using application checkout mix

### **Delivery**

- · Instrument manual for running the method
- CD-ROM with method parameters and checkout data files for easy out-of-the-box operation
- Application related consumables included no separate ordering required
- · Easy consumables re-ordering information

### Installation

- Duplicate factory checkout with checkout sample onsite by factory-trained support engineer
- · Optional application startup assistance



### Perform fast, unattended analysis and produce stable results using these built-in features:

- **Pre-configuration and chemical testing** ensure optimal performance for ppm-to %-level analysis in high-purity gas streams.
- Multi-column, multi-detector configurations maximize the data obtained from a single analysis.
- Capillary Flow Technology (CFT) reduces analysis time, improves data, and minimizes the need for system maintenance.
- Onsite installation and performance checkout confirm that your analyzer and application meet rigorous Agilent performance criteria.
- **System familiarization** enables your team to begin calibration and validation immediately following installation.

#### **Ordering information:**

Part Number	Analyzer Application
SP1 7890-0538	Permanent Gas Analyzer, Single Channel
SP1 7890-0573	Permanent Gas/Hydrogen Analyzer
G3445 Series #646	Low CO and $\mathrm{CO}_2$ in Process Gases Containing High $\mathrm{CH}_4$ Analyzer
G3445 Series #647	Low CO and CO <sub>2</sub> in Process Gas Analyzer
SP1 7890-0191	Inert Impurities in Pure Chlorine Analyzer
SP1 7890-0219	Trace Impurities in Helium Analyzer by PDHID
SP1 7890-0237	Impurities in Monomers Analyzer by PDHID
SP1 7890-0305	Inert Impurities in Crude Chlorine Analyzer
SP1 7890-0341	Trace Oxygenates and Hydrocarbons in Ethylene Analyzer
SP1 7890-0366	Trace CO and $\mathrm{CO}_2$ in Hydrogen and Light Gaseous Hydrocarbons Analyzer
SP1 7890-0409	Impurities in Ethylene/Propylene Analyzer by PDHID

### Put your applications on the fast track

Contact your local Agilent Representative or Agilent Authorized Distributor at **agilent.com/chem/contactus** 

Or call 800-227-9770 (in the U.S. or Canada)

Visit **agilent.com/chem/appkits** for a description of available Analyzers and Application Kits

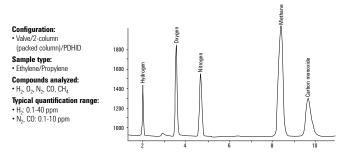
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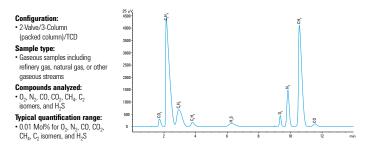
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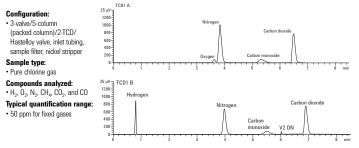
## Produce reproducible process-monitoring and quality-control data... day in and day out



Determination of impurities at 0.1 ppm. Matrix effects were eliminated by "cutting out" the matrix on a packed pre-column. Inert impurities (including  $H_2$ ,  $O_2$ ,  $N_2$ , CO, and  $CH_4$ ) were separated on a packed column.



This mixture of  $O_2$ ,  $N_2$ , CO,  $CO_2$ ,  $CH_4$ ,  $C_2$  isomers, and  $H_2S$  was analyzed in just 12 minutes.



Measurement of inert low-level impurities in pure chlorine. The chlorine was cut to the vent during sampling

